

INFORMATION DISCLOSURE STATEMENT

Applicant : Washio et al.
App. No : 10/560,155
Filed : December 9, 2005
For : DEVELOPER COMPOSITION FOR
RESISTS AND METHOD FOR
FORMATION OF RESIST PATTERN
Examiner : Le, Hoa Van
Art Unit : 1752

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 13 references to be considered by the Examiner. Also enclosed are 8 foreign patent references and/or non-patent literature as listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 8/24/07

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT	Application No.	10/560,155	
	Filing Date	December 9, 2005	
	First Named Inventor	Washio et al.	
	Art Unit	1752	
(Multiple sheets used when necessary)		Examiner	I.e, Hoa Van
SHEET 1 OF 1		Attorney Docket No.	SHIGA7.034APC

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
	1	3,207,725	09-1965	PFEIFER CHARLES R	
	2	7,063,937	06-2006	Takamiya, Shuichi	
	3	7,147,995	12-2006	Takamiya, Shuichi	
	4	20040185371	09-2004	Takamiya, Shuichi	
	5	6,451,510	09-17-2002	Messick et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
	6	JP 10010749	01-16-1998	Hoechst Ind. KK		√
	7	JP 2000155428	06-06-2000	Sumitomo Bakelite Co., Ltd.		√
	8	EP 0272686	06-29-1988	Fuji Photo Film Co., Ltd.		
	9	EP 0323836	07-12-1989	Fuji Photo Film Co., Ltd.		
	10	JP 61232453 (Abstract Only)	10-16-1986	Tokyo Ohka Kogyo Co., Ltd.		√
	11	JP 64072154 (Abstract Only)	03-17-1989	Tama Kagaku Kogyo KK		√

NON PATENT LITERATURE DOCUMENTS

Examiner Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ¹
	12	Office Action drafted July 27, 2007 in connection with Japanese Patent Application No. 2003-169834.	
	13	Office Action drafted July 31, 2007 in connection with Japanese Patent Application No. 2003-184708.	

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062407

Examiner Signature	Date Considered
<p>*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>	

T¹ - Place a check mark in this area when an English language Translation is attached.